

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Batzinger, et al.

Docket:

131253 (1306-30)

Serial No.:

≈‱res5

10/664 196

Examiner:

Not Yet Known

Filed:

September 17, 2003

Art Unit:

2858

For:

SYSTEM AND METHOD FOR

Dated:

February 5, 2004

MONITORING DEFECTS IN STRUCTURES

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

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Respectfully submitted,

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Jennifer Vitale